



MICRON.092CP1

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Stephen L. Willis
Appl. No. : 09/552,383
Filed : April 19, 2000
For : CHEMICAL MECHANICAL
PLANARIZATION OF
CONDUCTIVE MATERIAL
Examiner : Jose R. Diaz
Group Art Unit : 2815

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all
marked attachments are being deposited with
the United States Postal Service as first-class
mail in an envelope addressed to:
Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450, on

April 18, 2005
(Date)

Michael H. Trewholm, Reg. No. 37,743

RESPONSE TO OFFICE ACTION FILED WITH A REQUEST FOR CONTINUED
EXAMINATION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed October 20, 2004, please amend the above-captioned application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.